CENTRAL FAX CENTER

AUG 2 4 2009

S/N 10/565716

612-455-3801

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Murakami

Examiner:

Nguyen T. Ha

Serial No.:

10/565716

Group Art Unit:

2831

Filed:

January 25, 2006

Docket No.:

20162.0012USWO

Title:

METHOD FOR FORMING OXIDE FILM ON METAL SURFACE USING IONIC LIQUID, ELECTROLYTIC CAPACITOR AND ELECTROLYTE

THEREOF

CERTIFICATE UNDER 37 CFR 1.6(d):
I hereby certify that this paper is being transmitted by facsimile to the U.S. Patent and Trademark Office on August 24.

Mail Stop: AMENDMENT Commissioner for Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

RESPONSE

Dear Commissioner:

The following remarks are presented in response to the Office Action mailed May 27, 2009.

Remarks begin on page 2 of this paper.